Magnetic-Multilayered Interconnects Featuring Skin Effect Suppression

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Abstract—A novel concept for a high-frequency, low-loss interconnect with significant skin effect suppression over a wide frequency band is presented. The concept is based on a multilayer comprising thin magnetic (Ni$_{80}$Fe$_{20}$) and metal (Cu) layers. The negative permeability of the magnetic layers leads to a near-cancellation of the overall permeability of the multilayer stack. This results in a significant increase of skin depth and thus, a more uniform distribution of the current density and a dramatic reduction of loss within a certain frequency range. Coplanar waveguides built using the multilayer technology show more than 50% loss reduction at 14 GHz compared to their thick Cu-based counterparts.

Index Terms—Interconnections, magnetic layered films, magnetic resonance, microwave technology, transmission lines.

I. INTRODUCTION

INTERCONNECTS’ RC-delay (latency) imposes formidable challenges on speed, energy dissipation and signal integrity in giga/terascale integration [1]–[3]. The latency induced clock-edge degradation restricts the clock frequency, and consequently the speed of the entire system. The reduction of the interconnect latency is thus indispensable. Proposed in International Technology Roadmap for Semiconductors 2005 [4], the reduction of the RC latency relies mainly on developing improved low-$\kappa$ dielectrics. According to projections, however, the latency improvement will be limited to $\sim$26% by the year 2020.

The alternative to significantly reduce the interconnect latency at radio frequency (RF) is to lower the loss of the conductor. At RF, the loss in metal connections is governed by its finite conductivity $\sigma$ and the skin effect. Copper (Cu) is the metal of choice in today’s integrated electronics due to its high conductivity ($6 \times 10^7$ S/m), which is only $\sim$5% lower than that of silver, i.e., the highest conductivity existing in nature at room temperature. On the other hand, at RF, electric current tends to flow within a certain depth beneath the surface, i.e., within the skin depth $\delta = \sqrt{2/\omega \sigma \mu_0}$, where $\omega = 2\pi f$ with $f$ the frequency of the signal, and $\mu_0$ is the vacuum permeability. Increasing the conductor thickness beyond several skin depths does not effectively reduce the metal loss. Hence, the only option left to arrive at a lower metal loss, and thus RC latency, is to suppress the skin effect at RF. To be able to achieve this, the effective permeability in the conductor needs to be brought close to zero, or at least to a value much smaller than unity. The electric current will then flow more uniformly over the entire cross section of the conductor, similar to a dc current. Such a nearly ideal conductor having both maximum conductivity and near-zero permeability, however, does not yet exist.

In our previous work [5], a normal-metal/ferromagnetic multilayer (NFM) was proposed as a low loss conductor featuring suppression of the skin effect at high frequencies. Now, we experimentally demonstrate such an integrated low-loss conductor consisting of a bilayered Ni$_{80}$Fe$_{20}$/Cu multilayer for the first time. We show that a coplanar waveguide (CPW) based on NFM clearly exhibits skin-effect suppression. At 14 GHz, the line shows more than 50% reduction of conductor loss compared to an identical CPW built from thick Cu metallization.

II. EXPERIMENTS

Fig. 1 shows the sketch of a CPW transmission line built by using a metal/ferromagnetic multilayer. The Ni$_{80}$Fe$_{20}$ and Cu films in the stack were sputtered at room temperature with a thickness of $t_{\text{NiFe}} = 100$ nm and $t_{\text{Cu}} = 300$ nm, respectively. The total thickness of the Ni$_{80}$Fe$_{20}$/Cu stack was 6.7 $\mu$m. To adapt the stress induced by the sputtered Ni$_{80}$Fe$_{20}$ films, a soft
buffer layer of Benzocyclobutenes (BCB) was deposited between the Ni$_{80}$Fe$_{20}$/Cu stack and the nonalkaline Schott AF45 glass substrate. The electrical resistivity of the Cu and Ni$_{80}$Fe$_{20}$ layers was found to be 1.8 and 16.3 $\mu\Omega \cdot$cm, respectively. A dc magnetic field of $\sim$10 mT was applied during the Ni$_{80}$Fe$_{20}$ film deposition to induce magnetocrystalline anisotropy. The measured coercivities of the magnetic films were 2 and 5 mT, along the magnetic easy- and hard-axis, respectively.

The multilayer was patterned by wet etching into a CPW line with a signal linewidth of 90 $\mu$m and signal-ground spacing of 40 $\mu$m. The length of the line was 2.5 mm. For comparison, an identical CPW line was built by using a uniform 6.7 $\mu$m-thick Cu layer on a BCB/glass substrate. S-parameter measurements were performed on an Agilent HP 8510 Vector Network Analyzer after LRM calibration and used to extract the electrical characteristics of the lines. An external dc magnetic field of $\sim$10 mT was applied during the measurements and, consequently, the skin effect remains partially suppressed to that of the Cu line. At 14 GHz $\delta_{\text{eff}}$ reaches its peak which is reflected as the dip in resistance per unit length of the NFM line.

III. RESULTS AND DISCUSSION

In Fig. 2, we have compared the resistance per unit length of the Cu line to that of the NFM line saturated in two different directions. While at low frequencies the longitudinally saturated ($H_{\text{EXT}}$//z-axis) NFM line exhibited higher conductor loss compared to the Cu line, it showed significantly lower loss near 14 GHz. Compared to the Cu line, the conductor loss of the NFM line was more than 50% lower at this frequency, leading to a twice higher quality factor (Fig. 3). The other characteristic parameters of the CPW (inductance and capacitance per unit length) were found to be virtually unaffected by the NFM (results are not shown here).

To qualitatively understand the frequency dependence of the conductor loss, we have computed the effective skin-depth $\delta_{\text{eff}} = 1/(|\text{Re}(\sigma_\perp H)\mu_\perp|)$ in the NFM where $\sigma_{\text{eff}} = (\sigma_{\text{NiFe}}t_{\text{NiFe}} + \sigma_{\text{Cu}}t_{\text{Cu}})/t$ and $\mu_{\text{eff}} = \mu_\parallel (\sigma_{\text{NiFe}}t_{\text{NiFe}} + t_{\text{Cu}})/t$ denote average conductivity and permeability of the multilayer, respectively. Here, $t_{\text{NiFe}} + t_{\text{Cu}}$, $\sigma_{\text{NiFe}}$ and $\sigma_{\text{Cu}}$ represent the bulk conductivity of Ni$_{80}$Fe$_{20}$ and Cu, respectively, and $\mu_\parallel$ is the in-plane permeability of a Ni$_{80}$Fe$_{20}$ film. The latter is a function of frequency and is given by

$$\mu_\perp = \frac{(\Omega_H + \omega M)^2 - \omega^2}{\Omega_H^2(\Omega_H + \omega M) - \omega^2}$$

where $\Omega_H = \gamma H_a + j\omega \alpha$ and $\omega M = \gamma M$ where $H_a$ is the static anisotropy field, $M(\sim 1$T) is the saturation magnetization, $\gamma$ is the gyrotropic constant, and $\alpha(\sim 0.01)$ is the Gilbert damping constant [6]. The result of the calculation is plotted as an inset in Fig. 2. For comparison, the skin depth in Copper ($\delta_{\text{Cu}}$) is also shown.

At frequencies below 10 GHz the effective skin depth in the multilayer is smaller than the skin depth in the Cu conductor. This is caused by the large (negative) real part of $\mu_\perp$ and, consequently, $\mu_{\text{eff}}$. A smaller skin depth, together with a lower effective conductivity ($\sigma_{\text{eff}} < \sigma_{\text{Cu}}$ by $\sim$25%), explains the higher conductor loss observed in the multilayered CPW at low frequencies. With increasing frequency, however, the real part of $\mu_\perp$ becomes less negative [7] and $\delta_{\text{eff}}$ increases, eventually crossing $\delta_{\text{Cu}}$ near 10 GHz. It is then not surprising that the NFM and Cu lines show nearly the same resistance per unit length near this frequency. At 14 GHz, the real part of $\mu_{\text{eff}}$ becomes zero and $\delta_{\text{eff}}$ reaches its peak value, causing the dip observed in the conductor loss of the NFM line. As the frequency is further increased, the real part of $\mu_{\text{eff}}$ becomes positive, and $\delta_{\text{eff}}$ becomes smaller again. Our calculation shows that the skin effect remains partially suppressed ($\delta_{\text{eff}} > \delta_{\text{Cu}}$) up to 28 GHz. (Note, that results beyond 16 GHz are affected by $\lambda/4$ resonance effects and insufficient measurement accuracy, therefore, are not shown here.)

With the external magnetic field applied in the direction perpendicular to the line ($H$//x-axis), the dip in the conductor loss becomes much weaker and the result approaches to that of...
the Cu CPW. This provides another proof of the magnetic origin of the conductor loss minimum in the multilayer CPW and can be understood as follows. The application of the external field along the x-axis aligns the static magnetization inside the Ni$_{80}$Fe$_{20}$ layers with the magnetic field induced by the RF current. The magnetic layers then behave as normal metals, i.e., with unit permeability [6], and the overall behavior of the stack approaches that of a conventional metal.

The frequency ($f_s$) at which the skin-effect suppression occurred depends on the ratio $\xi = t_{Cu}/t_{NiFe}$ [5]. Whereas a ratio of 3 led to $f_s = 14$ GHz in our experiments, decreasing (increasing) $\xi$ shifts $f_s$ to higher (lower) values, with an upper limit given by $\gamma(M + H_a)/2\pi$, i.e., the maximum frequency at which the magnetic layers still exhibit a negative permeability. Although the maximum operation frequency of Ni$_{80}$Fe$_{20}$-based multilayers is $\sim 28$ GHz, much higher values can be achieved by using magnetic films with a high saturation magnetization. Calculations based on CoFe films ($M_s \sim 2.45$ T) predict $\sim 2.6$ times loss reduction at 60 GHz compared to Cu interconnects. Elaborate calculations such as in [5] show that even lower conductor loss can be achieved by using thinner metal and ferromagnetic layers and ferromagnetic layers with lower magnetic loss (smaller $\alpha$).

It is important to note that, in principle, on-chip multilayer wires do not require an external dc magnetic field. This is because the magnetic shape anisotropy due to the elongated shape of the magnetic films in the multilayer aligns the static magnetization parallel to the wire [8]. In our experiments, however, the excessive strain and stress in the multilayer deteriorated the magnetic alignment of the films, making the application of a bias field necessary. We believe that this problem can be addressed by using alternative deposition techniques (e.g., electroplating) to release the stress in the films. Alternatively, one can think of using self-biased ferromagnetic layers with an intrinsically high magnetocrystalline anisotropy. Finally, note that the application of multilayer conductors is not limited to transmission line interconnects. Skin-effect suppression can, in principle, be employed to reduce the conductor loss of any RF component including spiral inductors and transformers. However, care has to be taken to align the static magnetization of the magnetic films inside the multilayered wires to lie in parallel with the wires’ direction.

IV. CONCLUSION

We have reported a new concept of a low-loss conductor for RF interconnects, which allows for suppression of the skin effect. We showed that a CPW line built from a metal/magnetic multilayer exhibits more than 50% reduction of conductor loss compared to a conventional Cu line. We believe that this new concept provides a new means of advancing high-frequency and high-speed electronics.

REFERENCES